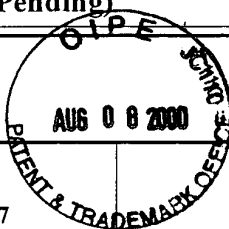


C 6AU-1765

TRANSMITTAL LETTER (General - Patent Pending)	Docket No. 11675.114
---	-------------------------

In Re Application Of: Kei-Yu Ko



Serial No. 08/846,671	Filing Date April 30, 1997	Examiner Goudreau	Group Art Unit 1765
--------------------------	-------------------------------	----------------------	------------------------

Title: **UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH
OF DOPED SILICON DIOXIDE**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Transmittal of Information Disclosure Statement (2 pgs); Supplemental Information Disclosure Statement (3 pgs);
Form PTO-1449; Promptness Certification (2 pgs); Copy of reference cited; Postcard

#12
8/15/00
M/W
IC 1700 MAIL ROOM
MAILED
AUG 10 2000

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of _____ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 23-3178 as described below. A duplicate copy of this sheet is enclosed.
- ☐ Charge the amount of _____
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.


Signature

Bradley K. DeSandro, Reg. No. 34,521


Dated: July 27, 2000



22901

PATENT TRADEMARK OFFICE

CC:

I certify that this document and fee is being deposited on July 28, 2000 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.	
 Signature of Person Mailing Correspondence	
Peggy R. Huft Typed or Printed Name of Person Mailing Correspondence	

Dated this 22 day of July 2000.

Respectfully submitted,



BRADLEY K. DeSANDRO
Attorney for Applicant
Registration No. 34,521

WORKMAN, NYDEGGER & SEELEY
1000 Eagle Gate Tower
60 East South Temple
Salt Lake City, Utah 84111
Telephone: (801) 533-9800
Facsimile: (801) 328-1707

BKD:prh
Enclosures
Docket: 11675.114

G:\DATA\WPDOCS3\PRHBKD\MICRON\IDS\PROMPT-CERT_114.DOC